

APPLICATION DATA SHEET (37 CFR 1.76)

APPLICATION INFORMATION

Title Line One:: STEAM CLEANING SYSTEM AND METHOD
Title Line Two:: FOR SEMICONDUCTOR PROCESS EQUIPMENT
Total Drawing Sheets:: 1
Formal Drawings:: Yes
Application Type:: Non-Provisional - Utility
Attny Docket Number:: QC-001-1C
Suggested Group Art Unit:: 2
Suggested Drawing for Pub::
Filing Date:: September 16, 2003

INVENTOR INFORMATION

Inventor One Given Name:: David
Middle Initial:: S.
Family Name:: Zuck
Postal Address Line One:: 1332 West Honeysuckle Lane
City:: Chandler
State or Province:: AZ
Postal or Zip Code:: 85248
Citizenship Country:: United States

INVENTOR INFORMATION

Inventor One Given Name:: Kurtis
Middle Initial:: R.
Family Name:: Macura
Postal Address Line One:: 16350 Highway 115
City:: Colorado Springs
State or Province:: CO
Postal or Zip Code:: 80926
Citizenship Country:: United States

CORRESPONDENCE INFORMATION

Correspondence Customer No.:: 27,946
Name:: Arthur J. Behiel
Address Line One:: 6601 Koll Center Parkway
Address Line Two:: Suite 245
City:: Pleasanton
State or Province:: CA
Country:: United States
Postal or Zip Code:: 94566

Telephone:: (925) 621-2113
Fax:: (925) 621-2114
Electronic Mail:: Art@SiliconEdgeLaw.com

REPRESENTATIVE INFORMATION

Registration Number: 39,603
Representative Name:: Arthur J. Behiel
Address Line One:: 6601 Koll Center Parkway
Address Line Two:: Suite 245
City:: Pleasanton
State or Province:: CA
Country: : United States
Postal or Zip Code:: 94566
Telephone:: (925) 621-2113
Fax:: (925) 621-2114
Electronic Mail:: Art@SiliconEdgeLaw.com

DOMESTIC PRIORITY CLAIM

This application is a continuation of 09/879,412 entitled, "Steam Cleaning System and Method for Semiconductor Process Equipment," filed 06/11/01, by inventors David S. Zuck and Kurtis R. Macura and therefore claims the benefit under 35 U.S.C. §120.

CONTINUITY INFORMATION

This application is a:: Continuation of
> Application One:: 09/879,412
Filing Date: 06/11/2001
Status:: Pending

FOREIGN PRIORITY INFORMATION

(None)